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PATENT
8075-1015

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Rikizo HATAKEYAMA et al.

Application No. 10/552,709

Filed October 7, 2005

METHOD AND APPARATUS FOR PRODUCING GAS ATOM
CONTAINING FULLERENE, AND GAS ATOM CONTAINING
FULLERENE

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 2, 2005

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying document, copy of which is attached to this statement, is made of record on the enclosed Form PTO-1449.

A concise explanation of the relevance of this item is that this reference was discovered during any searches they or their client had made, or that they were considered in the preparation of the application.

Respectfully submitted,

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* Abstract provided for the Examiner's convenience